



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

September 20, 2025

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG735589740

LABORATORY GROWN DIAMOND

OVAL MODIFIED BRILLIANT

8.10 x 5.94 x 4.95 mm

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

EXCELLENT

D

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

Inscription(s)

EXCELLENT

EXCELLENT

NONE

 LG735589740

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

LG735589740

Report verification at [igi.org](https://www.igi.org)

PROPORTIONS

14.5%

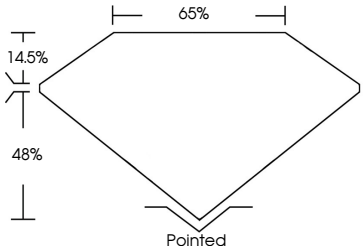
48%

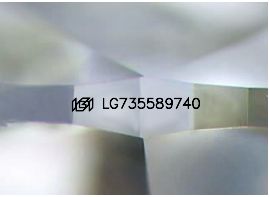
65%

83.3%

Pointed

Medium To Slightly Thick (Faceted)





Sample Image Used

LIGHT PERFORMANCE REPORT

Light Performance Grade: **Exceptional**



Structured Light Environment Representation

Moderate

High

Superior

Exceptional

Light Performance

Brightness

Fire

Contrast

COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

IF

VS 1 - 2

VS 1 - 2

SI 1 - 2

I 1 - 3

Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included

Included



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OVAL MODIFIED BRILLIANT

8.10 X 5.94 X 4.95 MM

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Table

Depth

Girdle

Medium To Slightly Thick (Faceted)

Pointed

EXCELLENT

EXCELLENT

NONE

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